

<b>FORM PTO-1449</b> <b>SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT</b>  <b>IN AN APPLICATION</b> (Use several sheets if necessary)	Docket Number: 10873.1283US01	Application Number: 10/656,483
	Applicant: SHIMAMURA et al.	
	Filing Date: September 5, 2003	Group Art Unit: 1745

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
RH	2003/0096168 A1	5.22.2003	KASAMATSU et al.				
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FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
RH ↓	01/67528 A1	13.09.2001	WIPO			SEE IDS	
	01/78167 A1	18.10.2001	WIPO			SEE IDS	
	1 274 140 A1	08.01.2001	EUROPE				
	1 028 476 A1	16.08.2000	EUROPE				
	1 109 239 A1	20.06.2001	EUROPE				
	02/07239 A1	24.01.2002	WIPO			SEE IDS	
	1 302 994 A1	16.04.2003	EUROPE				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
RH		Wachtler M et al.: "Tin and tin-based intermetallics as new anode materials for lithium-ion cells" Journal of Power Sources, Elsevier, Amsterdam, NL, vol. 94, no. 2, 1 March 2001 (2001-03-01), pages 189-193.					
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EXAMINER	/Robert Hodge/	DATE CONSIDERED	09/18/2006
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FORM 1449\*

## INFORMATION DISCLOSURE STATEMENT

Docket Number:

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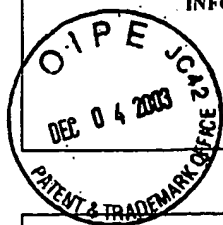
IN AN APPLICATION

(Use several sheets if necessary)

Applicant: SHIMAMURA et al.

Filing Date: September 5,  
2003

Group Art Unit: Unknown



## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
RH	5,770,333	06.1998	Saito et al.			
RH	6,090,505	07.2000	Shimamura et al.			

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
RH	2002-298836	11.2002	Japan			Abstract	
↓	2000-30703	01.2000	Japan			See IDS	
	9-63651	03.1997	Japan			See IDS	
	7-240201	09.1995	Japan			Abstract	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

RH		"Brillouin scattering of $\text{TiSi}_2$ : elastic constants and related thermodynamic parameters" R. Pastorelli et al., microelectronics Engineering, 55(2001) 129-135

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EXAMINER

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DATE CONSIDERED

09/18/2006

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